

Search Notes

Application/Control No.

10/825,110

Examiner

John Rivell

Applicant(s)/Patent under
Reexamination

CHEN, MEI-LI

Art Unit

3753

SEARCHED

| Class | Subclass | Date | Examiner |
|-------|---------------------------|-----------|----------|
| 137 | 625.17 625.4 625.41 | 7/13/2006 | |
| 251 | 313 | 7/13/2006 | |
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INTERFERENCE SEARCHED

| Class | Subclass | Date | Examiner |
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| Interference Search History Printout | | 7/13/2000 | |

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

| | DATE | EXMR |
|------------------------------|-----------|------|
| EAST Search History Printout | 7/13/2006 | |
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